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APPLICANTS

Jae-Kyu Lee, Kyungki-do, KOREA, REPUBLIC OF;

** CONTINUING DATA *****
none CDW** FOREIGN APPLICATIONS *****
REPUBLIC OF KOREA 2002-0043698 07/24/2002 CDWIF REQUIRED, FOREIGN FILING LICENSE GRANTED
** 03/31/2004

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <u>[Signature]</u> <u>[Initials]</u>	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 6	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 4
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ADDRESS

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TITLE

Method for forming shallow well of semiconductor device using low-energy ion implantation

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
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